#### MILITARY SPECIFICATION

# SEMICONDUCTOR DEVICE, TRANSISTOR, PNP, SILICON, LOW-POWER TYPE 2N1118

This specification is mandatory for use by all Departments and Agencies of the Department of Defense.

#### 1. SCOPE

- 1.1 Scope. This specification covers the detail requirements for a PNP, silicon, low-power transistor used in chopper, audio, and RF amplifier circuitry.
  - 1.2 Physical dimensions. See figure 1 (TO-5).
  - 1.3 Maximum ratings.

P <sub>T</sub> 1/	$v_{\mathrm{CBO}}$	$v_{\mathrm{EBO}}$	$v_{RT}$	$\mathrm{T}_{\mathbf{A}}$
mW	Vdc	Vdc	Vdc	<u>°C</u>
150	- 25	-20	-25	-65 to +140

1/ Derate linearly 1.31 mW/°C for  $T_{\mbox{\scriptsize A}} \geq 25^{\circ}$  C.

# 1.4 Primary electrical characteristics.

Timelia	C <sub>obo</sub>	$^{ m h_{fe}}$	f <sub>max</sub>	V <sub>EC</sub> (ofs)
Limits	$V_{CB} = -6 \text{ Vdc}$	-	$V_{\mathrm{CB}} = -6 \; \mathrm{Vdc}$	i
	$I_E = 0$	$I_E = 1 \text{ mAdc}$	$I_E = 1 \text{ mAdc}$	I <sub>E</sub> - 0
	100 kHz $\leq$ f $\leq$ 1 MHz			
	pf		MHz	mVdc
Min		15	8	
Max	9			5

### 2. APPLICABLE DOCUMENTS

2.1 The following documents, of the issue in effect on date of invitation for bids or request for proposal, form a part of the specification to the extent specified herein.

#### SPECIFICATION

#### MILITARY

MIL-S-19500 - Semiconductor Devices, General Specification for.

#### **STANDARD**

#### **MILITARY**

MIL-STD-750 - Test Methods for Semiconductor Devices.

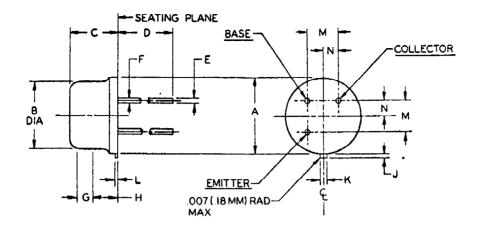
(Copies of specifications, standards, drawings, and publications required by suppliers in connection with specific procurement functions should be obtained from the procuring activity or as directed by the contracting officer.)

#### 3. REQUIREMENTS

- 3.1 General. Requirements shall be in accordance with MIL-S-19500, and as specified herein.
- 3.2 Abbreviations, symbols, and definitions. The abbreviations, symbols, and definitions used herein are defined in MIL-S-19500, and as follows:
- 3.3 Design, construction, and physical dimensions. Transistors shall be of the design, construction, and physical dimensions shown on figure 1.
- 3.3.1 Terminal-lead length. Terminal-lead length(s) other than that specified in figure 1 may be furnished when so stipulated under contract or order (see 6.2) where the devices covered herein are required directly for particular equipment-circuit installation or for automatic-assembly-technique programs. Where other lead lengths are required and provided, it shall not be construed as adversely affecting the qualified-product status of the device, or applicable JAN marking.
- 3.4 Performance characteristics. Performance characteristics shall be as specified in tables I, II, and  $\overline{\text{III}}$ .
- 3.5 Marking. The following marking specified in MIL-S-19500 may be omitted from the body of the transistor at the option of the manufacturer:
  - (a) Country of origin.
  - (b) Manufacturer's identification.

#### 4. QUALITY ASSURANCE PROVISIONS

- 4.1 Sampling and inspection. Sampling and inspection shall be in accordance with MIL-S-19500, and as specified herein.
- 4.2 Qualification inspection. Qualification inspection shall consist of the examinations and tests specified in tables  $I,\ II,\ and\ III.$
- 4.3 Quality conformance inspection. Quality conformance inspection shall consist of group A, B, and C inspections.
- 4.3.1 Group A inspection. Group A inspection shall consist of the examinations and tests specified in table I.
- 4.3.2 Group B inspection. Group B inspection shall consist of the examinations and tests specified in table  $\Pi$ .

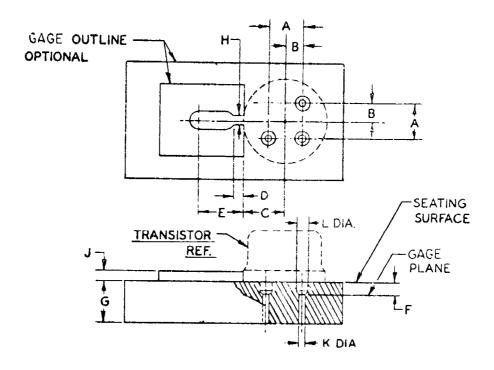


	DIMENSIONS							
LTR	INC	HES	MILLIM	ETERS	Z OF ES			
LIK	MIN	MAX	MIN	MAX	Š			
Α	.335	.370	8.51	9.40				
В	.305	.335	7.75	8.51				
C	.240	.260	6.10	6.60				
D	1.500	1.750	38.10	44.45	9			
E.	.016	.021	.41	.53	2,9			
F	.016	.019	.41	.48	3,9			
G	.100		2.54		4			
H					5			
厂	.029	.045	.74	1.14	8			
K	.028	.034	.71	.86				
L	.009	.125	.23	3.18				
M	.141	4 Nom	3.59	Nom	6			
N	.070	7 Nom	1.80	Nom	6			

T

- Metric equivalents (to the nearest .01 mm) are given for general information only and are based upon 1 inch = 25.4 mm.
   Measured in the zone beyond .250 (6.35 mm) from the seating plane.
- 3. Measured in the zone .050 (1.27 mm) and .250 (6.35 mm) from the seating plane.
- 4. Variations on dimension B in this zone shall not exceed .010 (.25 mm).
- 5. Outline in this zone is not controlled.
- 6. When measured in a gaging plane .054 +.001, -.000 (1.37 +.03, -.00 mm) below the seating plane of the transistor maximum diameter leads shall be within .007 (.18 mm) of their true location relative to a maximum width tab. Smaller diameter leads shall fall within the outline of the maximum diameter lead tolerance. Figure 2 shows the preferred measured method.
- 7. All leads shall be electrically insulated from the case.
- 8. Measured from the maximum diameter of the actual device.
- 9. All 3 leads.

FIGURE 1. Physical dimensions of transistor type 2N1118 (TO-5).



# NOTES:

- 1. The following gaging procedure shall be used: The use of a pin straightener prior to insertion in the gage is permissible. The device being measured shall be inserted until its seating plane is .125±.010 (3.18±.25 mm) from the seating surface of the gage. A spacer may be used to obtain the .125 (3.18 mm) distance from the gage seat prior to force application. A force of 8 oz ±.5 oz shall then be applied parallel and symmetrical to the device's cylindrical axis. When examined visually after the force application (the force need not be removed) the seating plane of the device shall be seated against the gage.
- The location of the tab locator, within the limits of dimension C, will be determined by the tab and flange dimension of the device being checked.
- Metric equivalents (to the nearest .01 mm) are given for general information only and are based upon 1 inch = 25.4 mm.

DIMENSIONS							
LTR	INC	HES	MILLIMETERS				
	MIN	MAX	MIN	МАХ			
Α	.1409	.1419	3.58	3.60			
В	.0702	.0712	1.78	1.81			
С	.182	.199	4.62	5.05			
D	.009	.011	<b>.</b> 23	.28			
Ε	.12	5 Nom	3.18 Nom				
F	.054	.055	1.37	1.40			
G	.372	.378	9.45	9.60			
Н	.0350	.0355	.89	.90			
J	.150	) Nom	3.81	Nom			
Κ	.0325	.0335	.83	.85			
L	.0595	.0605	1.51	1.54			

FIGURE 2. Gage for lead and tab location for transistor type 2N1118.

- 4.3.3 Group C inspection. Group C inspection shall consist of the examinations and tests specified in table III. This inspection shall be conducted on the initial lot and thereafter every 6 months during production.
- 4.3.4 Group B and group C life-test samples. Samples that have been subjected to group B, 340-hours life-test, may be continued on test to 1,000 hours in order to satisfy group C life-test requirements. These samples shall be predesignated, and shall remain subjected to the group C 1,000-hour acceptance evaluation after they have passed the group B, 340-hour acceptance criteria. The cumulative total of failures found during 340-hour test and during the subsequent interval up to 1,000 hours shall be computed for 1,000-hour acceptance criteria.
- 4.4 Methods of examination and test. Methods of examination and test shall be as specified in tables I, II, and III, and as follows:
- 4.4.1 Emitter to collector offset voltage. The transistor shall be tested in the circuit of figure 3. The base current shall be adjusted to the specified value. The voltage between the emitter and collector shall then be measured using a voltmeter with an input impedance high enough that halving it does not change the measured value within the required accuracy of the measurement.
- $4.4.2~{
  m Voltage}$ , reach-through, collector to emitter. An adequate forward dc current shall be applied to the emitter terminal, and a reverse dc voltage shall be applied between collector and base, starting at zero and increasing until the emitter-to-base voltage has reached the specified reverse value. The dc voltage between the collector and the base terminals shall then be measured. The  ${
  m V}_{
  m RT}$  will be equal to the reverse collector-to-base dc voltage less the reverse emitter-to-base dc voltage.

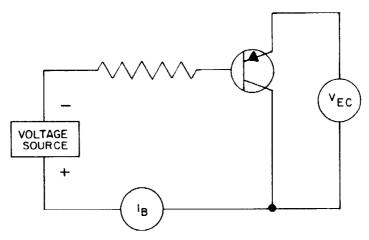


FIGURE 3. Emitter to collector offset voltage test circuit.

TABLE I. Group A inspection.

		MIL-STD-750			Li	mits	
Examination or test	Method	Details	LTPD	Symbol	Min	Max	Unit
Subgroup 1	,,,,,,,,,	2013110	10	37111301	, M(1)	mu^	0
Visual and mechanical examination	2071		10				
Subgroup 2			7				
Breakdown voltage, collector to base	3001	Bias cond. D; I <sub>C</sub> = -1 μAdc		BV <sub>CBO</sub>	-25		Vdc
Breakdown voltage, emitter to base	3026	Bias cond. D; $I_E$ = -1 $\mu$ Adc		BVEBO	-20		Vdc
Collector to base cutoff current	3036	Bias cond. D; V <sub>CB</sub> = -10 Vdc		ICBO		-0.1	μ <b>A</b> dc
Collector to base cutoff current	3036	Bias cond. D; V <sub>CB</sub> = -25 Vdc		I <sub>CBO</sub>		-1.0	μ <b>Adc</b>
Emitter to base cutoff current	3061	Bias cond. D; V <sub>EB</sub> = -10 Vdc		I <sub>EBO</sub>		-0. 1	μ <b>Adc</b>
Reach through voltage		V <sub>EB</sub> = -1 Vdc (see h.4.2)	İ	V <sub>RT</sub>	-25		Vdc
Emitter to collector offset voltage		$I_B = -1 \text{ mAdc}; I_E = 0$ (see 4.4.1 and figure 3)		V <sub>EC</sub> (ofs)		5	mVdc
Small-signal short-circuit forward-current transfer ratio	3206	$V_{CB} = -6 \text{ Vdc}$ $I_{E} = 1 \text{ mAdc}$		h <sub>fe</sub>	15		
Subgroup 3			10				
Collector-base time constant		$V_{CB} = -6 \text{ Vdc}; I_E = 1 \text{ mAdc}$ (see figure 4)		r <sub>b</sub> 'C <sub>c</sub>		5,000	psec
Open circuit output capacitance	3236	$V_{CB}$ = -6 Vdc; $I_E$ = 0; 100 kHz $\leq$ f $\leq$ 1 MHz		C <sub>obo</sub>		9	pf
Small-signal short-circuit input impedance	3201	$V_{CB} = -6 \text{ Vdc};$ $I_{E} = 1 \text{ mAdc}$		h <sub>ib</sub>		90	ohms
Small-signal open-circuit output admittance	3216	$V_{CB} = -6 \text{ Vdc};$ $I_E = 1 \text{ mAdc}$	} ;	h <sub>ob</sub>		2.5	μmhos
Maximum frequency of oscillation	3311	$V_{CB}$ = -6 Vdc; $I_{E}$ = 1 mAdc (see figure 5)		f <sub>max</sub>	8		MHz
Subgroup 4			15				
High-temperature operation:		$T_A = +125^{\circ} C$					
Collector to base cutoff current	3036	Bias cond. D; V <sub>CB</sub> = -25 Vdc		I <sub>CBO</sub>		-25	μ <b>A</b> dc
Low-temperature operation:		$T_A = -55^{\circ} C$					
Small-signal short- circuit forward-current transfer ratio	3206	$V_{CB}$ = -6 Vdc; $I_{E}$ = 1 mAdc		<sup>h</sup> fe	10		

TABLE II. Group B inspection.

	* 11	MIL-STD-750	I MDD		Li	mits	
Examination or test	Method	Details	LTPD	Symbol	Min	Max	Unit
Subgroup 1			20				
Physical dimensions	2066	(see figure 1)					
Subgroup 2			15				
Solderability	2026						
Thermal shock (temperature cycling)	1051	Test cond. C, except T(high) = +140° C					
Thermal shock (glass strain)	1056	Test cond. B					
Moisture resistance	1021						
End points:	2020	Diagrams D.		Ţ	1	1.0	
Collector to base cutoff current	3036	Bias cond. D; V <sub>CB</sub> = -25 Vdc		<sup>I</sup> CBO		-1.0	μ <b>A</b> dc
Small-signal short-circuit forward-current transfer ratio	3206	$V_{CB}$ = -6 Vdc; $I_{E}$ = 1 mAdc		h <sub>fe</sub>	15		
Subgroup 3	į		15				
Shock	2016	Nonoperating; 1500 G, 0.5 msec; 5 blows in each orientation: $X_1$ , $Y_1$ , $Y_2$ , and $Z_1$					
Vibration, variable frequency	2056	10 G					
Constant acceleration	2006	10,000 G; in each orientation: $X_1$ , $Y_1$ , $Y_2$ , and $Z_1$					
End points: (Same as subgroup 2)							
Subgroup 4			15				
Terminal strength (lead fatigue)	2036	Test cond. E					
End points: Seal (leak-rate)	1071	Test cond. G or H for fine leaks; test cond. A, C, D, or F for gross leaks				1x10 <sup>-7</sup>	atm cc/sec

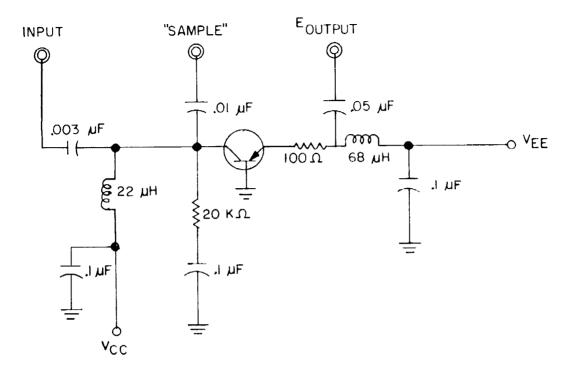
# MIL-S-19500/138C

TABLE II. Group B inspection - Continued.

aroup B Inspection - Continued.								
Examination or test		MIL-STD-750			Limits			
Examination of lest	Method	Details	LTPD	Symbol	Min	Max	Unit	
Subgroup 5			15					
Salt atmosphere (corrosion)	1041			<b>-</b>				
End points: (Same as subgroup 2)								
Subgroup 6			7			ļ ,		
High-temperature life (nonoperating)	1032	$T_{stg} = +140^{\circ} \text{ C}; \text{ time} = 340 \text{ hours (see 4.3.4)}$			- <b></b>			
End points: Collector to base cutoff current	3036	Bias cond. D; V <sub>CB</sub> = -25 Vdc		<sup>I</sup> CBO		-2	μ <b>Ad</b> c	
Small-signal short-circuit forward-current transfer ratio	3206	V <sub>CB</sub> = -6 Vdc; I <sub>E</sub> = 1 mAdc		h <sub>fe</sub>	12			
Subgroup 7			7					
Steady-state operation life	1027	$T_A = +25^{\circ} \text{ C};$ $V_{CB} = -10 \text{ Vdc}; P_T = 150 \text{ mW}; \text{ time} = 340 \text{ hours}$ (see 4.3.4)						
End points: (Same as subgroup 6)								

# TABLE III. Group C inspection.

Examination or test	MIL-STD-750				Limits		
	Method	Details	LTPD	Symbol	Min	Max	Unit
Subgroup 1			λ = 10				
High-temperature life (nonoperating)	1031	T <sub>stg</sub> = +140° C (see 4.3.4)					
End points: (Same as subgroup 6 of group B)							
Subgroup 2			λ = 10				
Steady-state operation life	1026	$T_A = +25^{\circ} C; V_{CB} = -10 \text{ Vdc}; P_T = 150 \text{ mW}$ (see 4.3.4)					
End points: (Same as subgroup 6 of group B)							



# PROCEDURAL NOTES:

- 1. Connect 10 MHz source to Input jack.
- 2. Connect \*RFVM to Sample jack\*\*.
- 3. Adjust 10 MHz level so that 1.6 V is read on RFVM.
- 4. Insert transistor into socket, apply bias, and set 10 MHz level for a 1.59 V reading on RFVM.
- 5. Connect RFVM to Output jack,  $r_b$ ' $C_c$  is read with 1 mV = 10 psec, 3 mV = 30 psec, etc., (the 1.59 Vin should be checked regularly during successive test measurements).
- \*RFVM = Boonton type 91CA or equiv; (high impedance); unterminated probe, Boonton type 91-6C adapter or equiv, to be used.
- \*\*Adapter BNC UG-491A/U, or equiv, to be used for connections to Input, "Sample", and Output jacks.

FIGURE 4. Collector-base time constant test circuit (an equivalent circuit may be used).

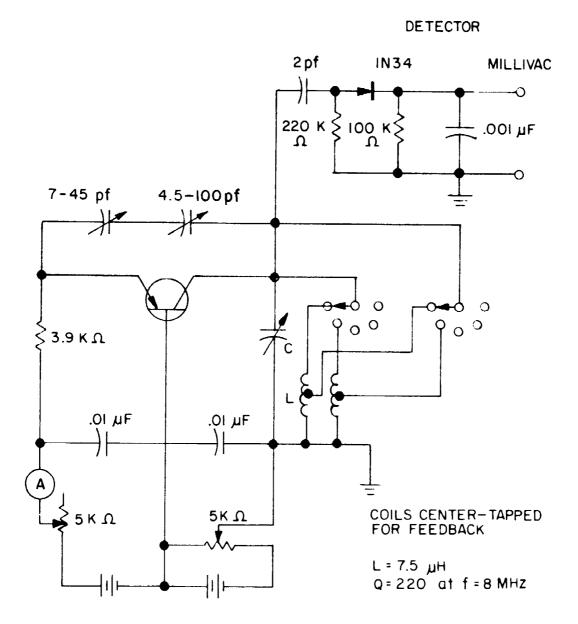


FIGURE 5. Maximum frequency of oscillation test circuit.

- 5. PREPARATION FOR DELIVERY
- 5.1 See MIL-S-19500, section 5.
- 6. NOTES:
- 6.1 Notes. The notes specified in MIL-S-19500 are applicable to this specification.
- 6.2 Ordering data. Procurement documents should specify the following:

Terminal-lead length if other than as specified in figure 1 (see 3.3.1).

Custodians:

Army - EL

Navy - EC

Air Force - 17

Review activities:

Army - MU, MI

Navy - SH

Air Force - 11, 85

DSA - ES

User activities:

Army - SM

Navy - CG, MC, OS, AS

Air Force - 13, 15, 19, 70, 80

Preparing activity: Army - EL

Agent:

DSA - ES

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